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FEB 25 2002

PTO/SB/08A (08-00)

Approved for use through 10/31/2002. OMB 0651-0031

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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  <i>(use as many sheets as necessary)</i>		<b>Application Number</b>	09/900,373
		<b>Filing Date</b>	July 6, 2001
		<b>First Named Inventor</b>	Li et al.
		<b>Group Art Unit</b>	2881
		<b>Examiner Name</b>	N/A
		<b>Attorney Docket Number</b>	NUFO 003
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U.S. PATENT DOCUMENTS						
Examiner Initials <sup>1</sup>	Cite No. <sup>1</sup>	U.S. Patent Documents		Name of Patentee or Applicant of Cited Documents	Date of Publication of Cited Document MM-DD-YYYY	Pages, columns, lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (if known)			
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Reprints

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FOREIGN PATENT DOCUMENTS						
Examiner Initials <sup>1</sup>	Cite No. <sup>1</sup>	Foreign Patent Documents		Name of Patentee or Applicant of Cited Documents	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Office <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)		
HV			EP0924628		Kessenich et al.	8/11/1998
HV			WO 98/44424		Marmor et al.	10/8/1998

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OTHER PRIOR ART—NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T <sup>2</sup>
HV		Favre et al.: 'External-Cavity Semiconductor Laser With 15 nm Continuous Tuning Range', Electronics Letters June 19 1986	
HV		Macleod, H. A. in Thin Film Optical Filters 2 <sup>nd</sup> Edition, McGraw-Hill, 1989, pgs 244-269	
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Examiner Signature		Date Considered	10/18/01
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